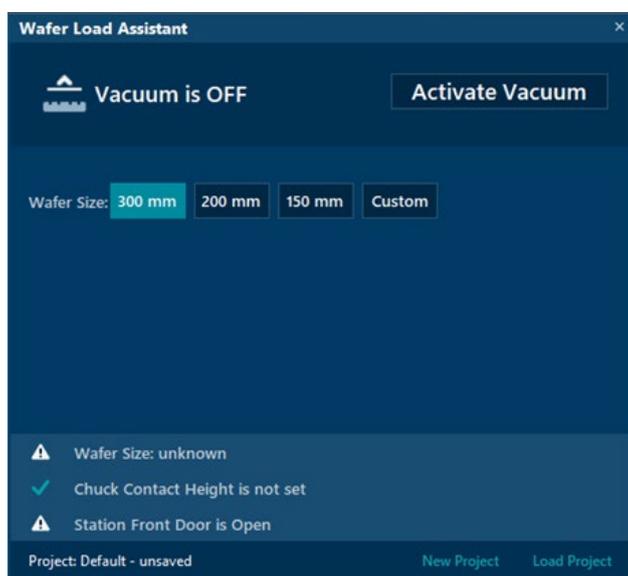**FORMFACTOR™**

Velox™ 3.4 Highlights
Probe Station Control Software

The most powerful engineering software in the market

Velox 3.4 focuses on detail improvements to the Wafer Map and Spectrum Vision. These improvements help the user to manage his daily tasks more effectively. The new Wafer Load Assistant enables more intuitive wafer handling. Velox 3.4 is available exclusively for Windows 10 IOT Enterprise 21H2 and supports the new MPX2 box.
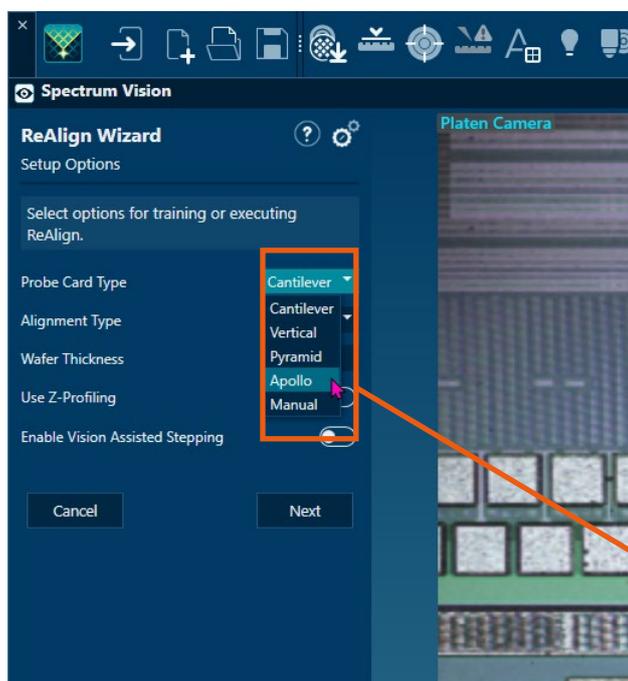
Windows 10 IOT Enterprise 21H2 requires an upgrade of the Probe Station PC. Please contact your local sales or service person for more information.

New Wafer Load Assistant

/ New modern graphical User Interface
/ The wafer size is now synchronized Velox-wide
/ The wizard guides through the wafer load process
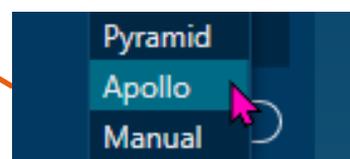/ Optionally the wafer alignment can be started directly from the wizard

Benefit:
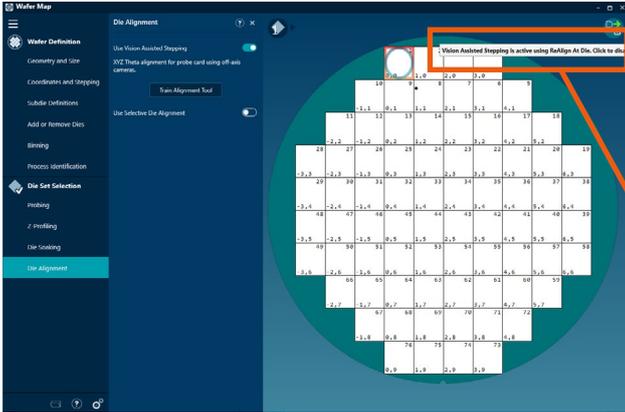Faster and smoother experience.

Spectrum Vision Enhancements

/ Align Chip is now integrated in Autonomous Assistant

/ CM300 now supports Apollo Probe Cards
/ Highly repeatable and reliable measurements thanks to FormFactor's Contact Intelligence
/ Perfect for pilot production tasks

Benefit:
The CM300 + Apollo Probe Card now closes the gap between use in the development and production environments.

Wafer Map

/ Vision Assisted Stepping – ReAlign is now integrated
/ Dies Table is back
/ Added Binning statistics

Vision Assisted Stepping is active using ReAlign At Die. Click to disab

General

/ Added support for the new MPX2 Box
/ Installation now requires Windows 10 IOT Enterprise 21H2
/ Bug fixes and various optimizations